## Substitute for form 1449A/PTO

Sheet

## (use as many sheets as necessary)

of

-	Complete if Known		
Application Number 10/729,511		10/729,511	
	Filing Date	December 4, 2003	
	First Named Inventor	Gregory BREYTA et al.	
	Art Unit	1713	
	Examiner Name	Unassigned	
	Attorney Docket Number	ARC920030073US1	

U.S. PATENT DOCUMENTS							
Examiner Initials*	Cite No.	Document No.	Issue Date or Publication Date	Name of Patentee or Applicant of Cited Document	Class	Subclass	Filing Date if Appropriate
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Examiner Initials*	Cite No.	Foreign Patent Document No.	Publication Date	Country	Class	Subclass	T	
Ϋ́V	AB	WO 01/86352	11/15/01	PCT		<del>                                     </del>	$\vdash$	
YV	AC	WO 02/079287	10/10/02	PCT				
YV	AD	WO 03/040827	5/15/03	PCT				

		OTHER DOCUMENTS — NONPATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), Title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Т
YV	AE	BAE et al. (2003), "Rejuvenation of 248 nm Resist Backbones for 157 nm Lithogrpahy," Journal of Photopolymer Science and Technology 14(4):613-620.	
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- [	Examiner		Date	
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-	Signature	/ lovgony varontou/	Considered	11/14/2006
-	F3/43 45 455		Considered	

<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.